Tool ID	
Tool Status	Running Wafers
Location	
Wafer Size	300 mm
Fab Section	Lithography
Tool Available Date	

General Product Information

Vendor Supplier	TEL
Model	LITHIUS
Vintage	2005
Serial No	
Asset Description	2-Block-Machine
Software Version	300.0.130.2 SECS
CIM	Coat, Development
Process	

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Factory Interface	FOUP	4	OK
Options System			
Others			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
Temp./ Hum.Controller	2	OK
PowerBox	1	OK
Resist Cabinet	1	OK
Developer Cabinet	1	OK
Coater Cabinet	1	OK

Missing/Faulty Parts / Accesorries List

Description	Quantity
NONE	